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JUNE 24, 2004

Date

Carolyn L. Ross
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Appl. No. : 09/970,100 Confirmation No. : 2699
Applicants : Vishnu K. Agarwal and Scott G. Meikle
Filed : October 2, 2001 Attorney Docket No. : 500453.04
Art Unit : 1762 Customer No. : 27,076
Examiner : William P. Fletcher
Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR
CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH
PADS AND MACHINES

REQUEST FOR CONTINUED EXAMINATION (RCE)
UNDER 37 C.F.R. § 1.114

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant requests continued examination, under 37 C.F.R. § 1.114, of the above-identified application.

1. Submission Required Under 37 C.F.R. § 1.114

- a. ☐ Submission previously submitted
 - i. ☐ Consider the amendment/reply under 37 C.F.R. § 1.116 previously filed on _____
 - ii. ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on _____

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02 FC:1201 86.00 DA